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**DEC 20 2004**

**PATENT**  
Customer No. 23494  
Attorney Docket No. TI-31620  
Application No.: 10/085,753

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
<b>TSUGA et al.</b>	)	Group Art Unit: 1746
	)	
Application No.: 10/085,753	)	Examiner: Michael Kornakov
	)	
Filed: February 28, 2002	)	
	)	
For: <b>METHOD AND DEVICE FOR</b>	)	
<b>REMOVING PARTICLES ON</b>	)	
<b>SEMICONDUCTOR WAFERS</b>	)	

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**


Applicants hereby petition for a three month extension of time to reply to the  
Office Action dated June 18, 2004, December 18 being a Saturday.

Please grant any extensions of time required to enter this response and charge  
any required fees to the Texas Instruments Incorporated Deposit Account 20-0668.

Respectfully submitted,

Dated: December 20, 2004

By: \_\_\_\_\_

  
Jonathan A. Hack  
Reg. No. 47,623